

	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/786,799	CHEN ET AL.	
İ	Examiner	Art Unit	
	Y. J. Han	2838	

SEARCHED				
Class	Subclass	Date	Examiner	
323	313			
<u>.</u>	314			
	316			
	274-281			
327	539			
	540			
323	317	3/17/2006	JH	

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Class	Subclass	Date	Examiner
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
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